

PRODUCT / PROCESS CHANGE INFORMATION

1. PCI basic data

1.1 Company		STMicroelectronics International N.V
1.2 PCI No.		AMS/21/12940
1.3 Title of PCI		Change of EWS test platform from C372 to DOT 100 on the selected products.
1.4 Product Category		See Products List
1.5 Issue date		2021-07-27

2. PCI Team

2.1 Contact supplier	
2.1.1 Name	ROBERTSON HEATHER
2.1.2 Phone	+1 8475853058
2.1.3 Email	heather.robertson@st.com
2.2 Change responsibility	
2.2.1 Product Manager	Andrea Mario ONETTI
2.1.2 Marketing Manager	Simone FERRI
2.1.3 Quality Manager	Michele CALDERONI

3. Change

3.1 Category	3.2 Type of change	3.3 Manufacturing Location
Equipment (EWS-FT)	Tester or prober duplication : qualification of a new equipment, which type (brand, and/or model, and/or options) already exists and is used on same application	CATANIA

4. Description of change

	Old	New
4.1 Description	EWS test platform: SPEA C372.	EWS test platform: SPEA DOT 100.
4.2 Anticipated Impact on form,fit, function, quality, reliability or processability?	NO IMPACT	

5. Reason / motivation for change

5.1 Motivation	C372 are old models as EWS Test Platform and are no more properly supported by suppliers.
5.2 Customer Benefit	SERVICE CONTINUITY

6. Marking of parts / traceability of change

6.1 Description	by dedicated FG code
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7. Timing / schedule

7.1 Date of qualification results	2021-06-25
7.2 Intended start of delivery	2021-10-11
7.3 Qualification sample available?	Upon Request

8. Qualification / Validation

8.1 Description	12940 G101463 Wfs 25 Porting summary report.pdf
8.2 Qualification report and qualification results	Available (see attachment)

Issue Date

2021-07-27

9. Attachments (additional documentations)

10. Affected parts		
10. 1 Current		10.2 New (if applicable)
10.1.1 Customer Part No	10.1.2 Supplier Part No	10.1.2 Supplier Part No
	ASM330LHHTR	

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ASM330LHHTR / KIT330LHHTR



TPGM ASIC EWS Porting from C372 to DOT

EWS Porting summary report

Author: Marco Morezzi / Francesco Cicchitano

Approver: Alfio Dimartino

Catania, 25/06/2021

Revision 1.0

Overview

SPEA C372 are old testers.

They are in production since 1998. SPEA cannot fully guarantee adequate support in case of tester problems.

Due to equipment obsolescence, we will move ASM330LHHTR / KIT330LHHTR ASIC from EWS test platform SPEA C372 to SPEA DOT 100.

SPEA DOT 100 is already used for consumer version of this product since many years

The following slides are showing that electrical results using the two tester models are equivalent

Change Traceability

- Traceability:
 - Same Commercial Product (CP) / Ordering Code will be used
 - New Finished Goods (FG) will be applied on the material produced with the new flow
 - Production transfer planned by week 40 (beginning of october 2021)

	CURRENT	NEW
ST Commercial Product	ASM330LHHTR	ASM330LHHTR
ST Marking	No change	No change
ST Finished Good (T&R)	ASM330LHHTR-M5F/	ASM330LHHTR- M B 5/
ST Commercial Product	KIT330LHHTR	KIT330LHHTR
ST Marking	No change	No change
ST Finished Good (TRAY)	KIT330LHHTR-M4F/	KIT330LHHTR- M B 5/

5M1E analysis

Change	4M	Control	Remarks
Testing transfer from ST CST to ST MLT	Machine	Tester : C372 from SPEA	Tester DOT100 from SPEA
	Man	Same EWS plant (Catania EWS)	No change
	Material	Same diffusion material	No change
	Measurement	Testing program is transferred from C372 to DOT 100	No change in testing results
	Method	Testing flow is unchanged: EWS (amb) EWS 2 (cold)	No change
	Environment	Catania plant is fully qualified for automotive production	No change

Qualification plan : correlation wafer

Lot: G101463;

Wf laser marking : 25;

Gross: 5124;

Flow: EWS1 (T amb), EWS2 (T cold -40°C);

VddMin= 1.71 V, VddCal= 2.5V, VddMax= 3.6 V;

Testing: Wf 25 tested before on DOT and then on C372

Purpose: to compare the EWS results.



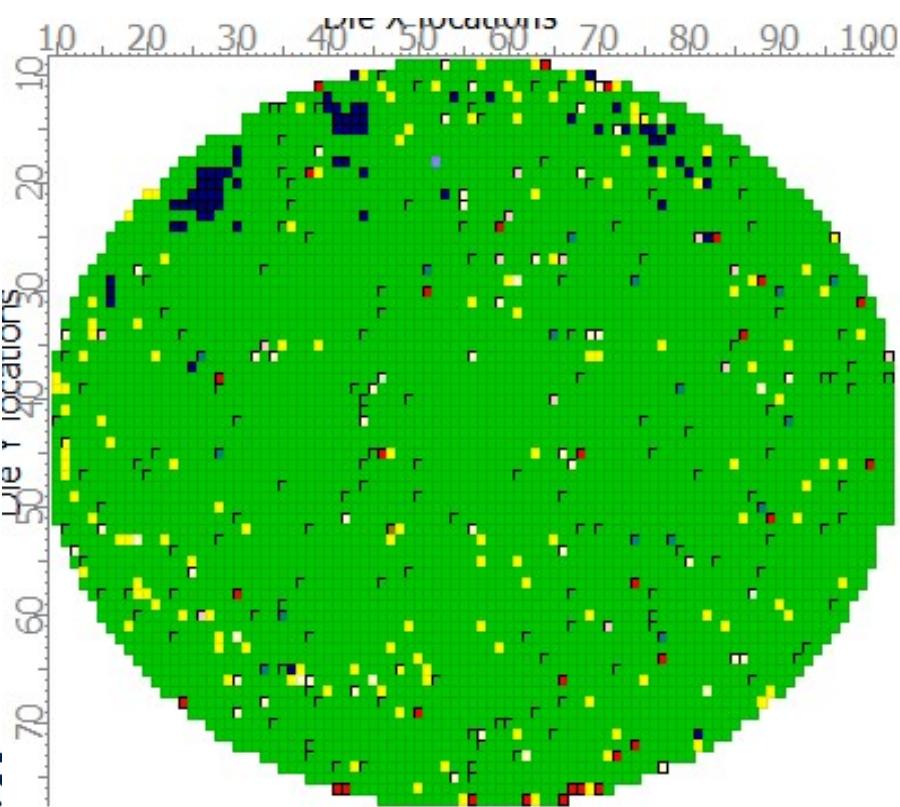
EWS1

ST Confidential

25 – EWS1 - Wafer map

Group name: C372

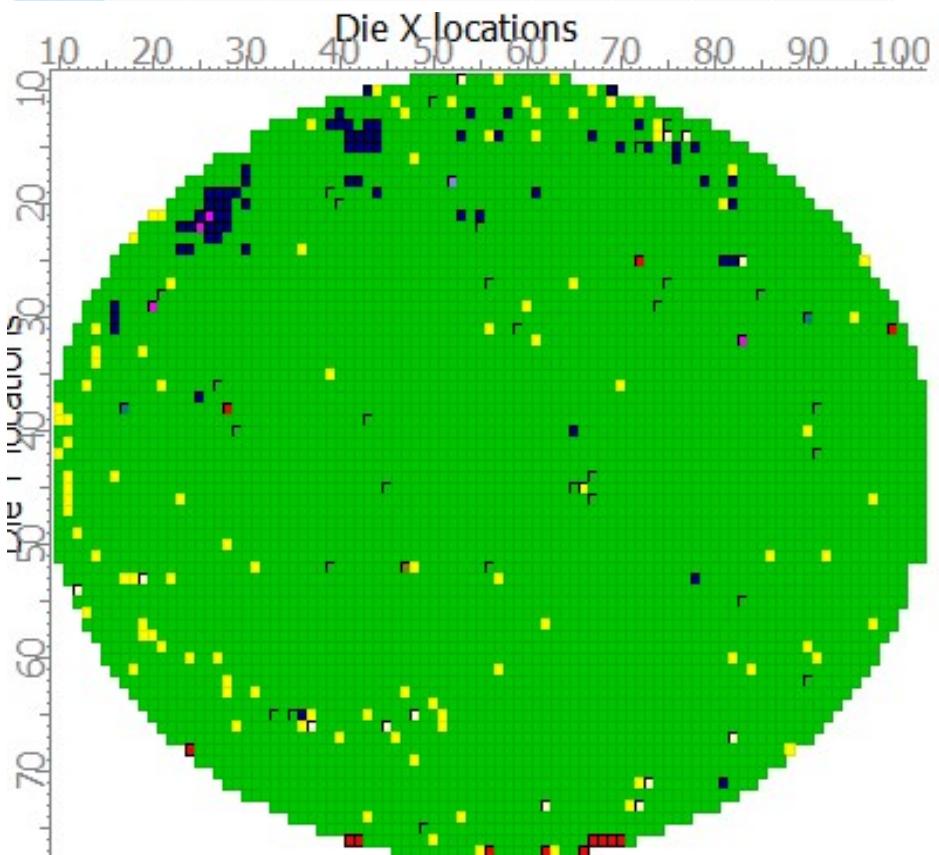
Top 10 Software Binning	1 Pass	4 Leakages	15 FIFO	18 Supply Current	3 Ram_Rom	11 LDO	12 Otp	16 EWS_test_GYRO	17 EWS_test_ACC
Color	Green	Yellow	Dark Blue	Red	Teal	Light Red	Light Yellow	Light Yellow	Light Yellow
Pass/Fail	P	F	F	F	F	F	F	F	F
Percentage	93.8%	2.7%	1.3%	0.7%	0.6%	0.3%	0.3%	0.2%	0.1%
Total count	4805	136	69	36	31	16	13	9	4



life.augmented

Group name: DOT

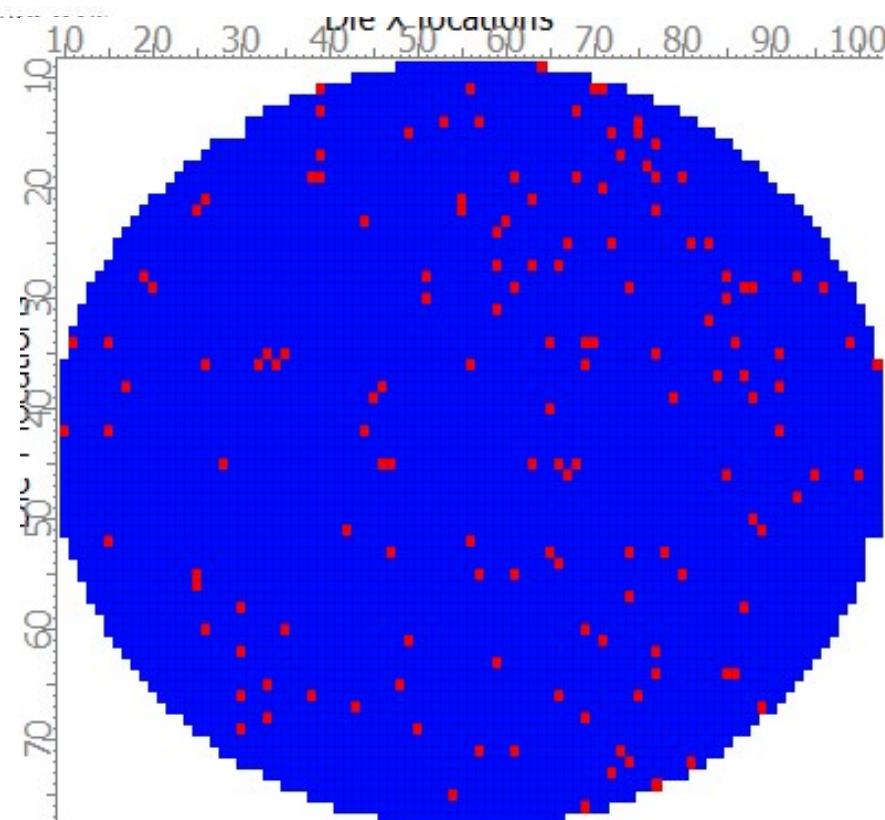
Top 10 Software Binning	1 Pass	4 Leakages	15 FIFO	3 Ram_Rom	17 EWS_test_ACC	5 Open	18 Supply Current	11 LDO	31 STMC_Ram_Test
Color	Green	Yellow	Dark Blue	Red	Light Yellow	Magenta	Light Yellow	Teal	Light Yellow
Pass/Fail	P	F	F	F	F	F	F	F	F
Percentage	96.0%	2.0%	1.3%	0.3%	0.1%	0.1%	0.1%	0.0%	0.0%
Total count	4920	101	69	13	4	4	4	2	2



25 – EWS1 - Wafer map

Delta yield summary table

	C372 - Wafer: G101463-25G5	DOT - Wafer: G101463-25G5
Total dies	5124	5124
Total PASS	4805	4920
Yield	93.77%	96.02%
Mismatch (all): 145	2.83%	2.83%
Mismatch (P->F): 8	0.16%	0.16%
Mismatch (F->P): 123	2.40%	2.40%



– EWS1 - Pass C372... Fail DOT100

Delta yield binning pareto: Pass to Fail

C372 - Wafer: G101463-25G5	DOT - Wafer: G101463-25G5	Frequency (#)
1	4	1
1	11	1
1	18	1
1	3	1
1	5	2
1	15	2
Total	-	8

C372, fail DOT, 8 dice:

- 1- 2 fail Sw Bin 15 (Hw Bin 15) → FIFO
- 2- 2 fail Sw Bin 5 (Hw Bin 5) → Open
- 3- 1 fail Sw Bin 3 (Hw Bin 10) → Ram_Rom
- 4- 1 fail Sw Bin 18 (Hw Bin 19) → Supply current
- 5- 1 fail Sw Bin 11 (Hw Bin 7) → LDO
- 6- 1 fail Sw Bin 4 (Hw Bin 11) → Leakage (with PD pre-calibration)

WF 25 – EWS1 - Pass DOT100... Fail C372

Delta yield binning pareto: Fail to Pass

C372 - Wafer: G101463-25G5	DOT - Wafer: G101463-25G5	Frequency (#)
13	1	2
15	1	6
16	1	7
12	1	10
11	1	14
3	1	18
18	1	32
4	1	34
Total	-	123

123 dicPass DOT, fail C372e:

- 1- 34 fail Sw Bin 4 (Hw Bin 11) → Leakage (with PD pre-calibration) → No reprobe of fail dice
- 2- 32 fail Sw Bin 18 (Hw Bin 19) → Supply Current
- 3- 18 fail Sw Bin 3 (Hw Bin 10) → Ram_Rom
- 4- 14 fail Sw Bin 11 (Hw Bin 7) → LDO
- 5- 10 fail Sw Bin 12 (Hw Bin 14) → OTP
- 6- 7 fail Sw Bin 16 (Hw Bin 17) → EWS test Gyro
- 7- 6 fail Sw Bin 15 (Hw Bin 15) → Fifo
- 8- 2 fail Sw Bin 13 (Hw Bin 9) → Temperature

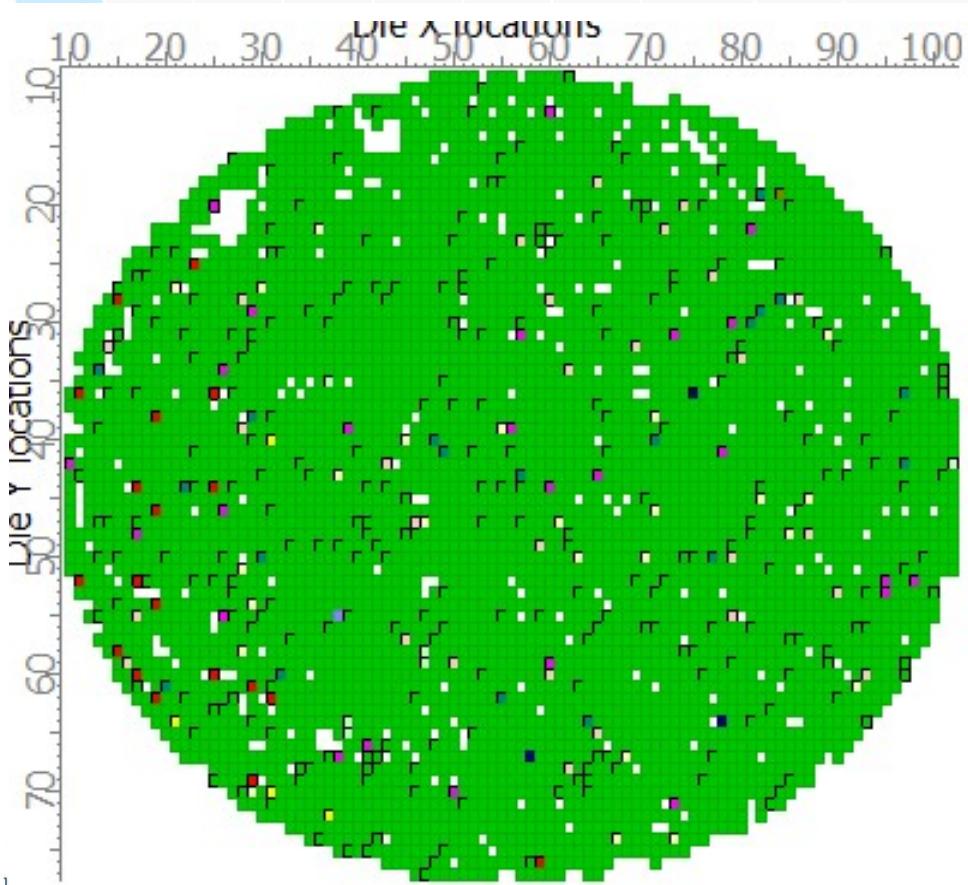
ALL THESE DIE WERE RETESTED ON C372 AND WERE NOT CONFIRMED FAILURES



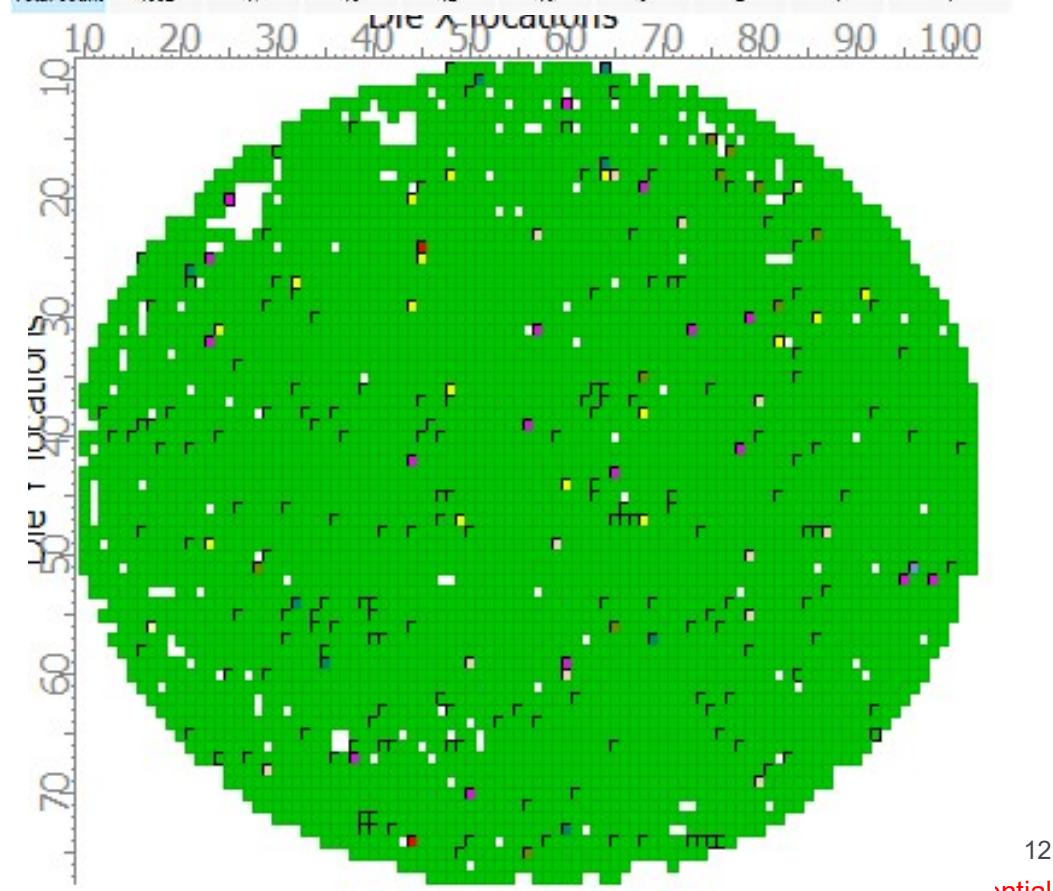
EWS2

WF 25 – EWS2 - Wafer map

Top 10 Software Binning	1 Pass	12 Otp	8 Scan Test	18 Supply Current	4 Leakages	11 LDO	14 Frequency_trim	5 Open	16 EWS_test_GYRO
Color	Green	Red	Magenta	Yellow	Red	Dark Teal	Light Green	Yellow	Dark Blue
Pass/Fail	P	F	F	F	F	F	F	F	F
Percentage	97.3%	0.6%	0.5%	0.5%	0.4%	0.4%	0.1%	0.1%	0.1%
Total count	4675	28	25	24	19	19	6	4	3



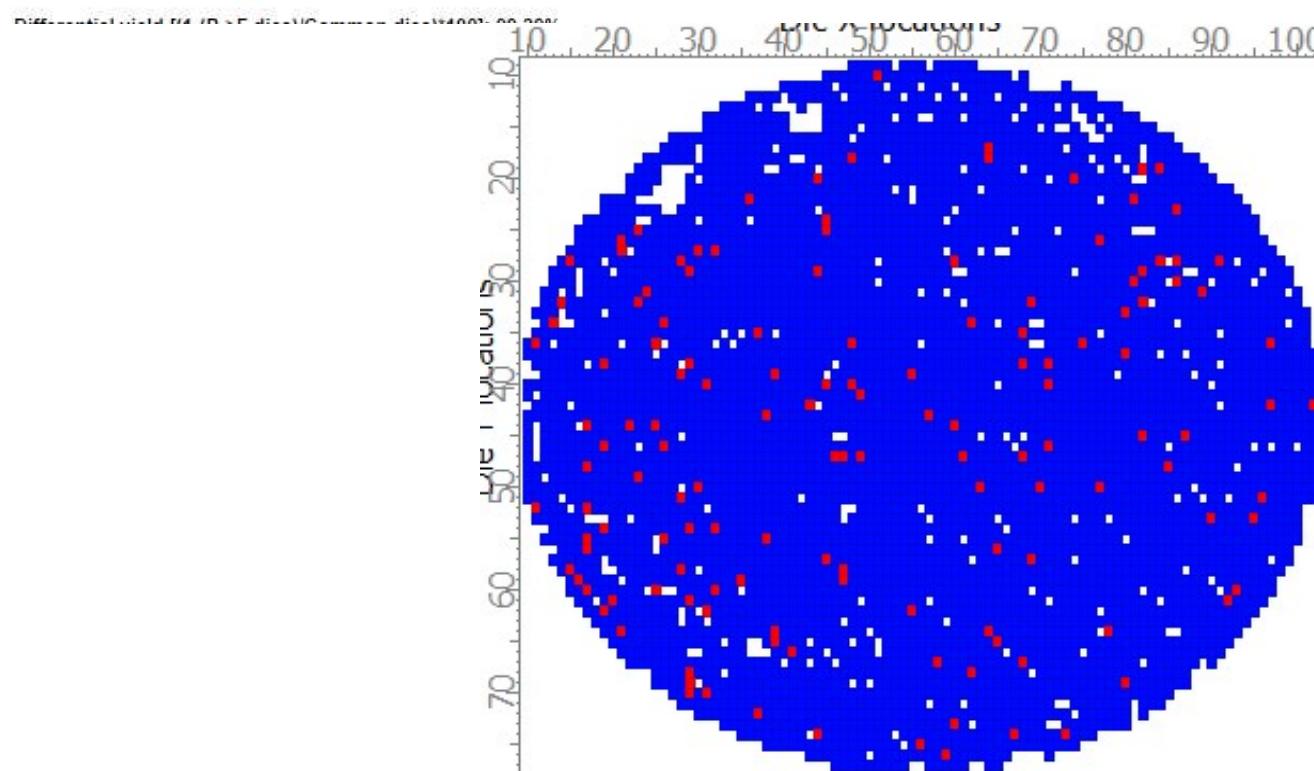
Top 10 Software Binning	1 Pass	8 Scan Test	5 Open	12 Otp	15 FIFO	11 LDO	4 Leakages	18 Supply Current	17 EWS_test_ACC
Color	Green	Magenta	Yellow	Red	Dark Olive Green	Dark Teal	Red	Yellow	Light Yellow
Pass/Fail	P	F	F	F	F	F	F	F	F
Percentage	98.6%	0.3%	0.3%	0.2%	0.2%	0.2%	0.0%	0.0%	0.0%
Total count	4852	17	16	12	10	8	2	1	1



WF 25 – EWS2 - Summary mismatch

Delta yield summary table

	C372 - Wafer: G101463-25G5	DOT - Wafer: G101463-25G5
Total dies	4805	4920
Total PASS	4675	4852
Yield	97.29%	98.62%
Mismatch (all): 140	2.91%	2.85%
Mismatch (P->F): 34	0.71%	0.69%
Mismatch (F->P): 101	2.10%	2.05%



WF 25 – EWS2 - Pass C372... Fail DOT100

Delta yield binning pareto: Pass to Fail

C372 - Wafer: G101463-25G5	DOT - Wafer: G101463-25G5	Frequency (#)
1	10	1
1	8	1
1	17	1
1	4	2
1	12	3
1	15	4
1	19	7
1	5	15
Total	-	34

Pass C372, fail DOT, 34 dice:

- 1- 15 fail Sw Bin 5 (Hw Bin 25) → Open
- 2- 7 fail Sw Bin 11 (Hw Bin 27) → LDO
- 3- 4 fail Sw Bin 15 (Hw Bin 35) → FIFO
- 4- 3 fail Sw Bin 12 (Hw Bin 34) → Otp
- 5- 2 fail Sw Bin 4 (Hw Bin 21) → Leakage (with PD pre-calibration)
- 6- 1 fail Sw Bin 17 (Hw Bin 24) → Ews test Acc
- 7- 1 fail Sw Bin 8 (Hw Bin 28) → Scan
- 8- 1 fail Sw Bin 10 (Hw Bin 31) → Current trim

Delta yield binning pareto: Fail to Pass

C372 - Wafer: G101463-25G5	DOT - Wafer: G101463-25G5	Frequency (#)
10	1	1
16	1	3
5	1	4
14	1	6
8	1	9
4	1	18
11	1	18
12	1	19
18	1	23
Total	-	101

DOT, fail C372, 101 dice:

- 1- 23 fail Sw Bin 18 (Hw Bin 29) → Supply Current
- 2- 19 fail Sw Bin 12 (Hw Bin 34) → OTP
- 3- 18 fail Sw Bin 11 (Hw Bin 27) → LDO
- 4- 18 fail Sw Bin 4 (Hw Bin 21) → Leakage (with PD pre-calibration)
- 5- 9 fail Sw Bin 8 (Hw Bin 28) → Scan test
- 6- 6 fail Sw Bin 14 (Hw Bin 36) → frequency trim
- 7- 4 fail Sw Bin 5 (Hw Bin 25) → Open
- 8- 3 fail Sw Bin 16 (Hw Bin 23) → EWS test Gyro
- 9- 1 fail Sw Bin 10 (Hw Bin 31) → Current trim

ALL THESE DIE WERE RETESTED ON C372 AND WERE NOT CONFIRMED FAILURES

WF 25 – Retest offline Pass DOT100... Fail C372

1. **C372 Wf 25 overall yield:** 91.24%;
2. **DOT Wf 25 overall yield:** 94.69%;

Main causes of mismatches between C372 and DOT:

1. Obsolescence of the C372 equipment (many retest on C372 are usually needed);
2. Obsolescence of the C372 setup
 - a) Capacitors mounted between VDD and GND on C372 probecard are different from those mounted on the probecard of the DOT (100 nF // 10uF Vs 100nF). This causes differences in small current measurements and digital tests performed with pattern;
 - b) Probecard of C372 with no impedance matching (creates an undesired effect of crosstalk issue).

All dies fail on C372 but pass on DOT have been retested with result **ALL PASS** confirming a poor performance of the equipment / setup C372.

Conclusion

DOT 100 is fully qualified to test ASM330LHHTR / KIT330LHHTR ASIC at EWS step.

Mismatch on the results between C372 e DOT100 are due to poor performance of C372

Thank you

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Public Products List

Public Products are off the shelf products. They are not dedicated to specific customers, they are available through ST Sales team, or Distributors, and visible on ST.com

PCI Title : Change of EWS test platform from C372 to DOT 100 on the selected products.

PCI Reference : AMS/21/12940

Subject : Public Products List

Dear Customer,

Please find below the Standard Public Products List impacted by the change.

ASM330LHHTR		
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